PATENT

Docket No.: O11.2I-11893-US01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Akihiro KAWASE, Toshihiro MIWA, Kenji

SAKAMOTO, Ichiro HAYASHIDA

Application No.: 10/533888

Filed: December 21, 2005

For: POLISHING COMPOSITION AND RINSING

COMPOSITION

Examiner: Binh X. Tran

Group Art Unit: 1792

Via Facsimile: 571-273-0025

Attn: Office of Petitions
Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REQUEST TO CORRECT ASSIGNEE UNDER 3.81(B)

In response to the denial of the United States Patent and Trademark Office to issue a Certificate of Correction, applicant offers the following statement.

Applicant affirms that Assignee, Fujimi Incorporated was inadvertently omitted from the Fee Transmittal Form PTOL-85B on December 17, 2008. Fujmi Incorporated should have been included on the Fee Transmittal Form PTOL-85 along, with Assignee, Wako Pure Chemical Industries, LTD.,

A copy of the Notice of Recordation of Assignment Document, dated August 31, 2005, Reel 016704, Frame 0046, which confirms that both Fujimi Incorporated and Wako Pure Chemical Industries, LTD are assignees, is provided.

Adjustment date: 10/20/2010 CKHLOK 02/03/2009 INTEFSW 00007006 10533888 01 FC:1811 -100.00 OP

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